



In re Patent Application of)
Shunpei YAMAZAKI et al.)
Serial No. 09/352,194)
Filed: July 13, 1999)
For: CRYSTALLINE SEMICONDUCTOR)
THIN FILM, METHOD OF)
FABRICATING THE SAME)
SEMICONDUCTOR DEVICE, AND)
METHOD OF FABRICATING THE)
SAME)

Art Unit: 2823
Examiner: Fernando L. Toledo

102800 MAIL 2002
RECEIVED
MAY 30 2002
CERTIFICATE OF MAILING
I hereby certify that this correspondence is being deposited with
The United States Postal Service with sufficient postage as First
Class Mail in an envelope addressed to: Commissioner for Patents,
Washington, D.C. 20231, on 5-22-02
Cesar M. Garcia

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith attached Form PTO-1449 listing references known to Applicant and requests that these references be made of record in the above identified application. Copies of the references listed are submitted herewith in accordance with 37 C.F.R. 1.98(a). It is requested that the accompanying information disclosure statement be considered and made of record in the above-captioned application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that the Examiner initial a copy of this form and return to the undersigned.

The references listed on the attached form PTO-1449 were cited in an Office Action dated April 24, 2002 in family Application Serial No. 09/894,125. The '125 application and the subject application share Japanese Priority Document No. 10-203205.

A *Request for Continued Examination* was filed on April 24, 2002 and no further Action has been received from the Patent Office. Therefore, no fee is required.

Respectfully submitted,


Eric J. Robinson
Reg. No. 38,285

Robinson Intellectual Property Law Office
PMB 955
21010 Southbank Street
Potomac Falls, Virginia 20165
(571) 434-6789 (Voice)
(571) 434-9499 (Facsimile)